

SHIGA7.035APC

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Washio et al.
Appl. No. : 10/561,802
Filed : December 22, 2005
For : DEVELOPER COMPOSITION
FOR RESISTS AND METHOD
FOR FORMATION OF RESIST
PATTERN
Examiner : Le, Hoa Van
Group Art Unit : 1752

CERTIFICATE OF FAX TRANSMISSION

I hereby certify that this correspondence and all marked attachments, are being transmitted via facsimile to Examiner Hoa Van Le at (571) 273-1332 on the date shown below:

August 10, 2010

(Date)

Total number of pages including this sheet: 3

Neil S. Bartfield, Ph.D., Reg. No. 39,901

SUPPLEMENTAL RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Remarks begin on page 2 of this paper.

A replacement abstract is appended as page 3 of this paper.

(Amendment)
Please enter
08/10/10
Hoa Van Le
HOA VAN LE
PRIMARY EXAMINER